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Application of:	Sang-In Lee et al.	Confirmation No.:	1997
Serial No.:	10/524,814	Art Unit:	2894
Filed:	May 5, 2006	Examiner:	SMITH, Bradley
For:	<i>Atomic Layer Deposition of High-K Metal Oxides</i>	Attorney Docket No:	067538-5170-US

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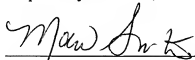
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Respectfully submitted,

Date: April 23, 2009



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